

Notice of References Cited	Application/Control No. 10/766,014		Applicant(s)/Patent Under Reexamination HAIDNER ET AL.	
	Examiner Andrew Hwa S. Lee		Art Unit 2886	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0030823	03-2002	Kobayashi et al.	356/485
*	B	US-6,736,510	05-2004	Van Heugten, Anthony	351/221
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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